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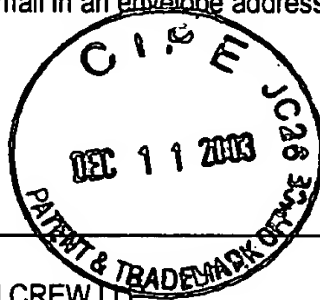
Commissioner for Patents,
P.O. Box 1450
Alexandria, VA 22313-1450

on December 9, 2003

TOWNSEND and TOWNSEND and CREW LLP

By

Andrea S. Beck



PATENT
Attorney Docket No.: AM3024/T28300
TTC No.: 016301-028300US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Fabrice Geiger, et al.

Application No.: 09/632,425

Filed: August 4, 2000

For: **Process for Depositing a Porous,
Low Dielectric Constant Silicon
Oxide Film**

Confirmation No.: 1892

Examiner: Lisa A. Kilday

Art Unit: 2829

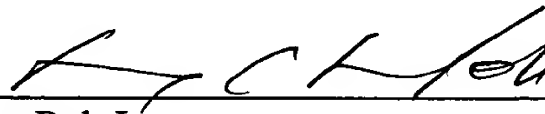
LETTER TO OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby submit 9 sheets of formal drawings to be made of record in the above-identified case.

Respectfully submitted,


Chun-Pok Leung
Reg. No. 41,405

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